

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of

SEUNG-CHUL CHOI

Group Art Unit:

Application No.:

Examiner:

Filed: December 16, 2003

Confirmation No.:

For: CHEMICAL VAPOR DEPOSITION APPARATUS AND METHOD

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. As this application is being filed after June 30, 2003, no copies of the cited U.S. patents, which are cited in the specification, are enclosed. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

As this Information Disclosure Statement is being filed with the application, no certification or fee is required.

Respectfully Submitted,

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Date: December 16, 2003

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<p>Application Number</p>					
<p>Filing Date</p>				<p>12/16/2003</p>	
<p>First Named Inventor</p>				<p>SEUNG-CHUL CHOI</p>	
<p>Art Unit</p>					
<p>Examiner Name</p>					
Sheet	1	of	1	<p>Attorney Docket Number</p> <p>040021-0306769</p>	

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U. S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS					
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This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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